

Notice of References Cited	Application/Control No. 09/873,614	Applicant(s)/Patent Under Reexamination WEISS ET AL.	
	Examiner Khiem D Nguyen	Art Unit 2823	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,627,090	05-1997	Marukawa et al.	438/167
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Shinji Matsui, Nanostructure Fabrication Using Electron Beam and Its application to Nanometer Devices (IEEE Vol. 85, No. 4, April 1997).
	V	Hoechst AG, Aromatic amides of mercapto-alkanoic acids-used as adhesive agents for photo-polymerisable copying layers an copper emulsion carriers (1999 Derwent Information LTD 1976-32210X).
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.